



PTO/SB/08A (08-03)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Complete if Known

Application Number	10/683,822
Filing Date	October 10, 2003
First Named Inventor	Yong-Hang Zhang
Art Unit	2815
Examiner Name	Jerome Jackson Jr.
Attorney Docket Number	9138-0137

Sheet 1 of 2

U. S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	1	US- 6,506,618	01-14-2003	Kizuki et al	
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FOREIGN PATENT DOCUMENTS

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Sheet

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	2	YANG, X. et al, "Molecular beam epitaxial growth of InGaAsN:Sb/GaAs quantum wells for long-wavelength...", Applied Physics Letters, Jul 12, 1999, p 178-180, Vol 75, No 3	
	3	STORM, D. F. et al, "Surfactant effects of thallium in the epitaxial growth of indium...", Journal of Applied Physics, May 1, 1999, p 6838-6842, Vol 85, No 9	
	4	KASPI, R. et al, "Surfactant-Mediated Growth of AlGaAs By Molecular Beam Epitaxy," Materials Research Society Symposium Proceedings, Apr 17-20, 1995, p 79-85, Vol 379	
	5	YANG, et al, "Low threshold InGaAsN/GaAs single quantum well lasers grown by....," Electronics Letters, June 24, 1999, p 1082-1083, Vol 35, No 13	

Examiner Signature		Date Considered	2/05
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